

FIG. 1

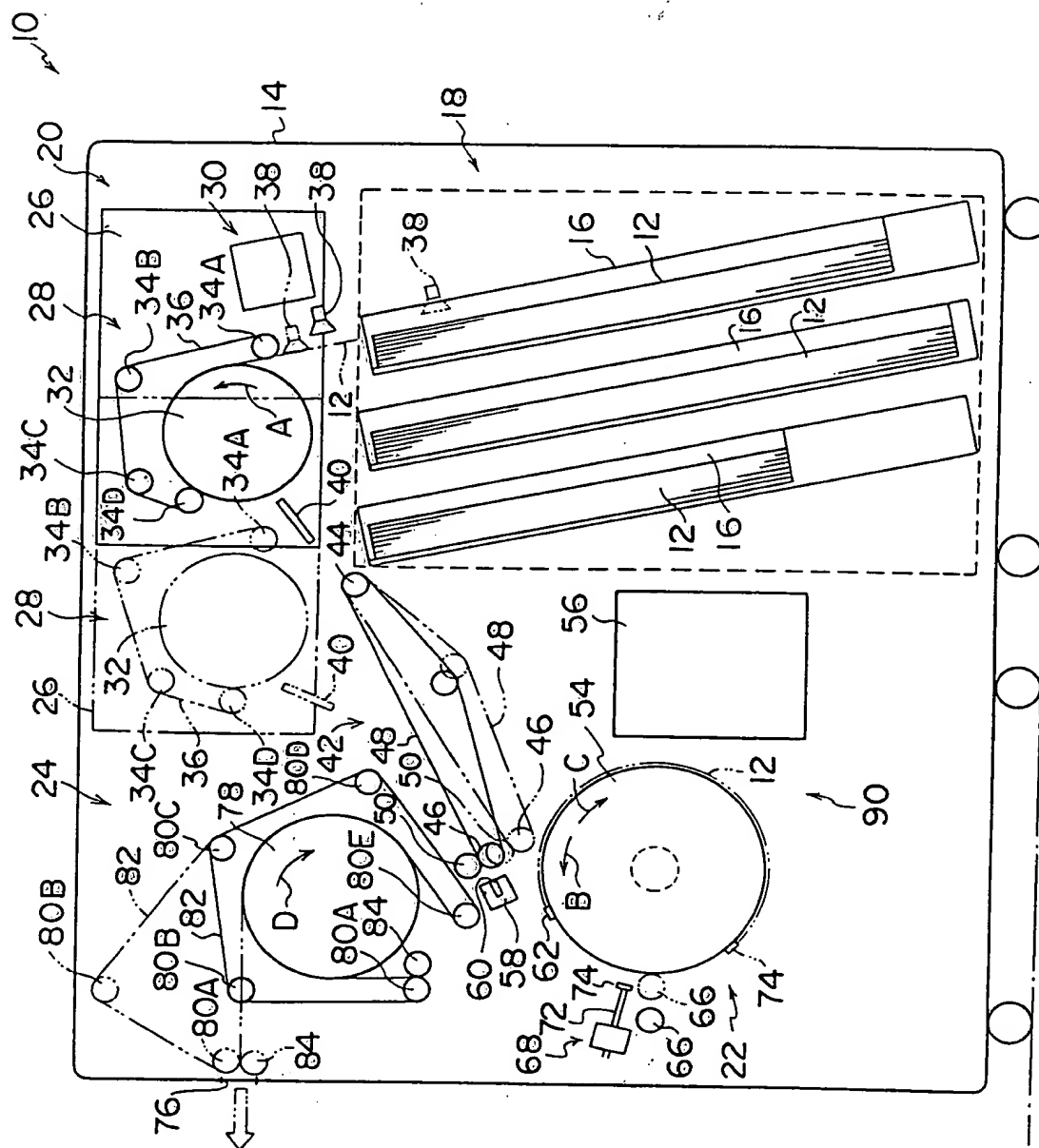
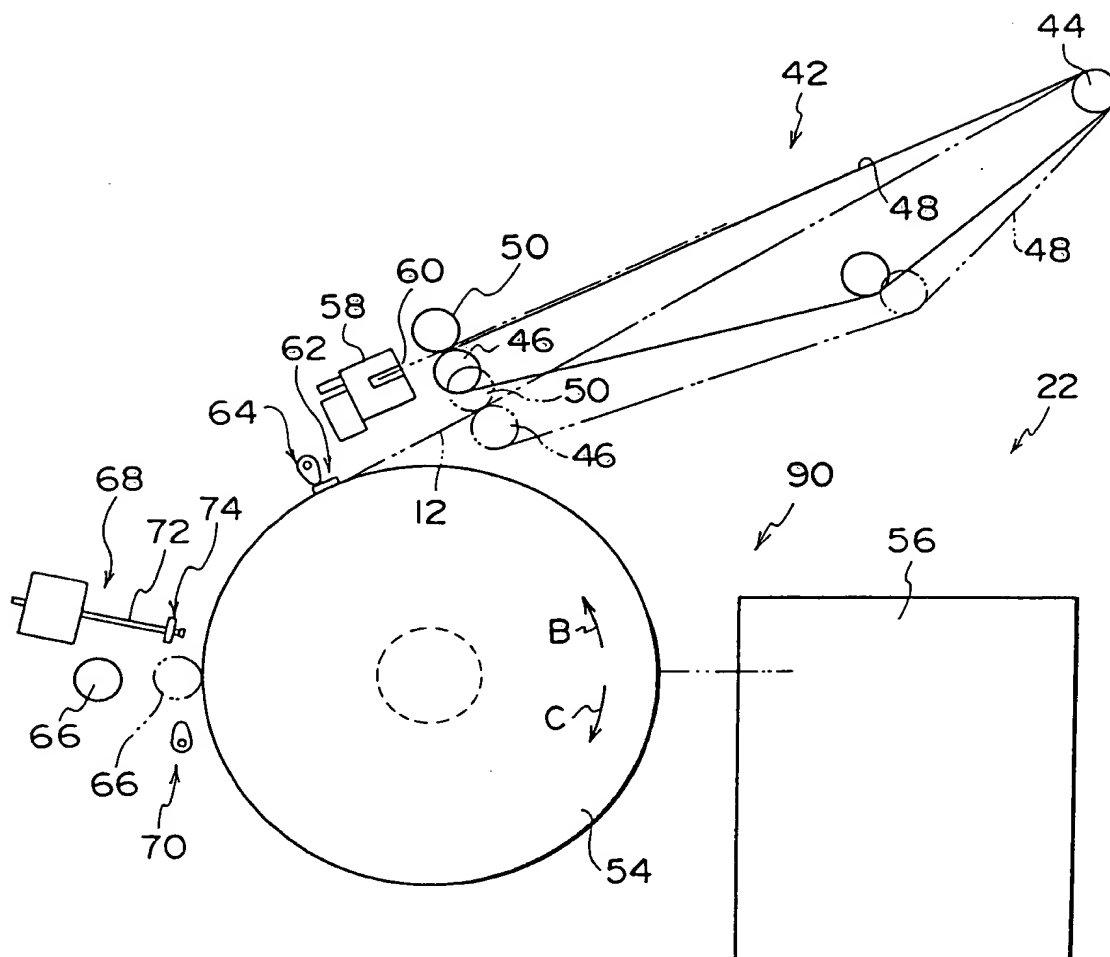


FIG. 2



091260 **Q** **07** **01**

FIG. 3

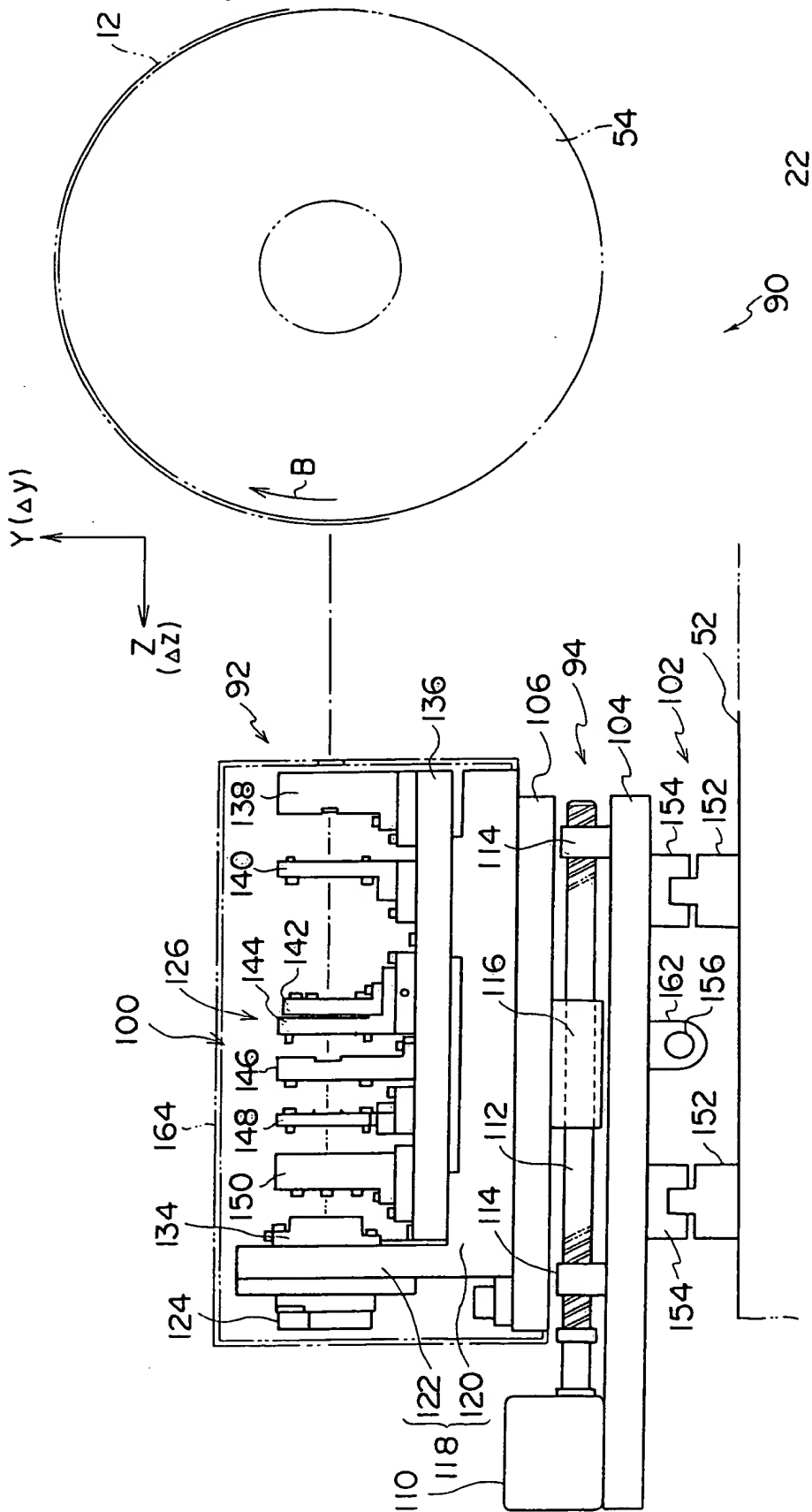


FIG. 4

22

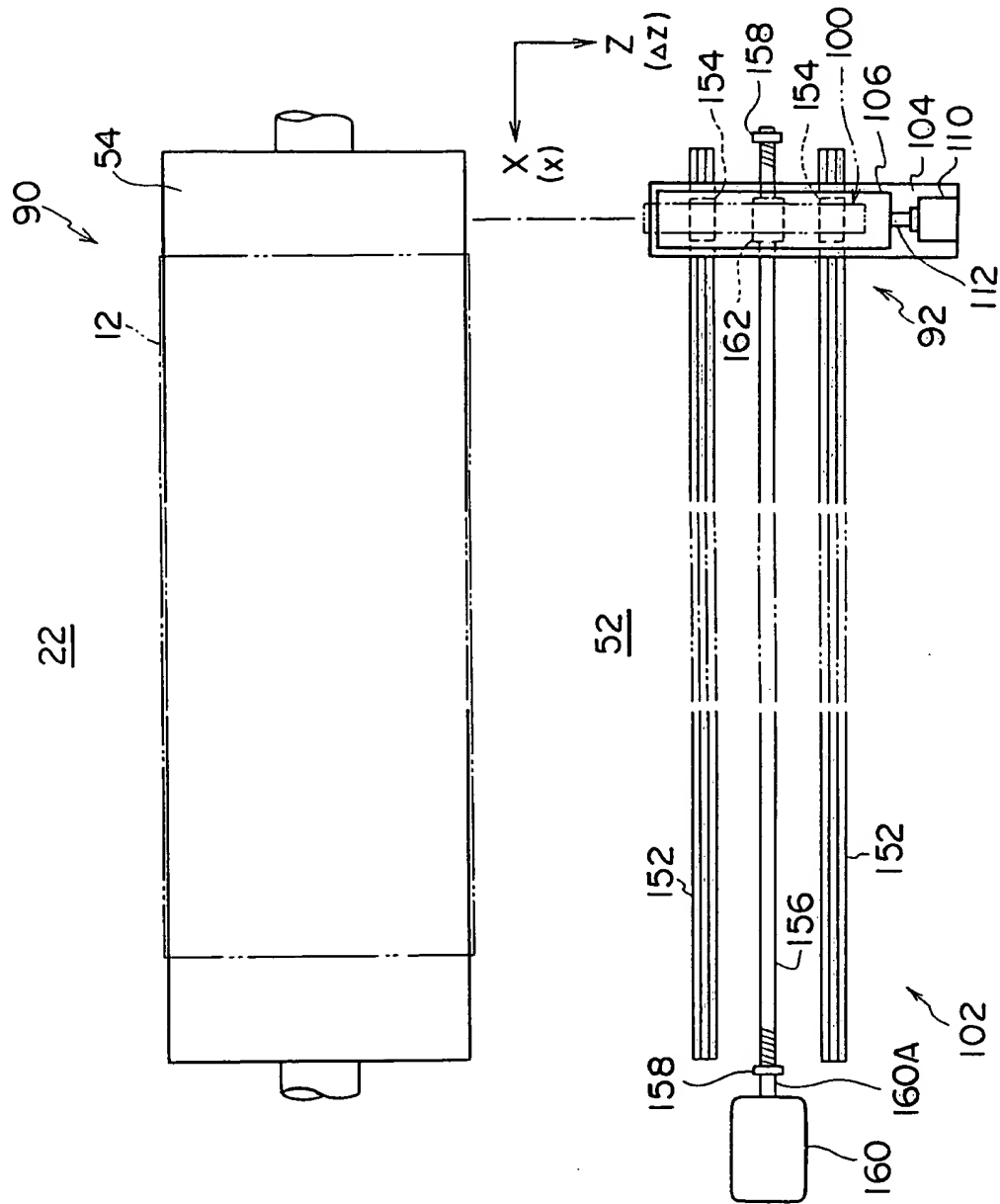


FIG. 5

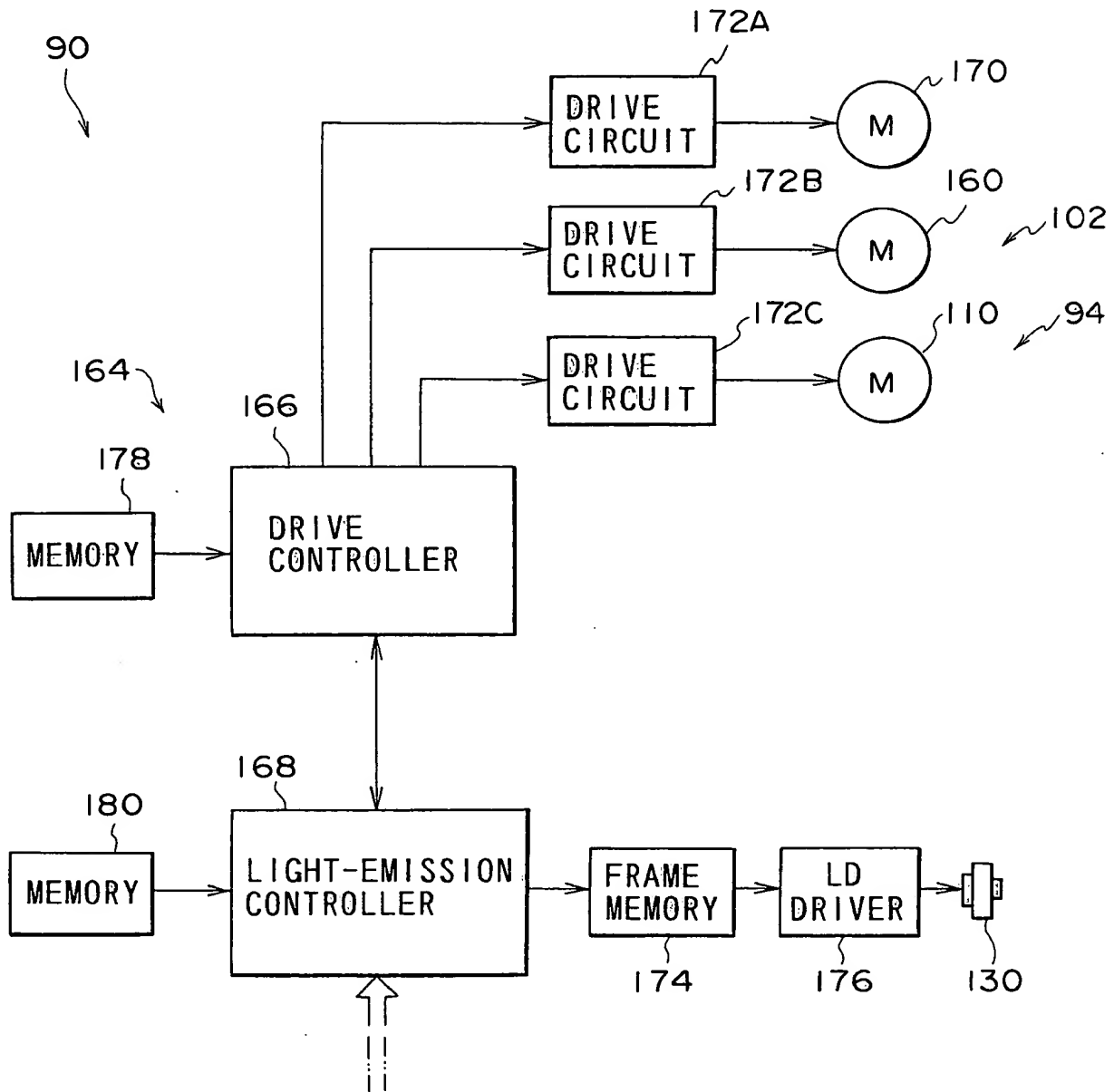


FIG. 5

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 AN SCAN-EXPOSURE APPARATUS
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FIG. 6 A

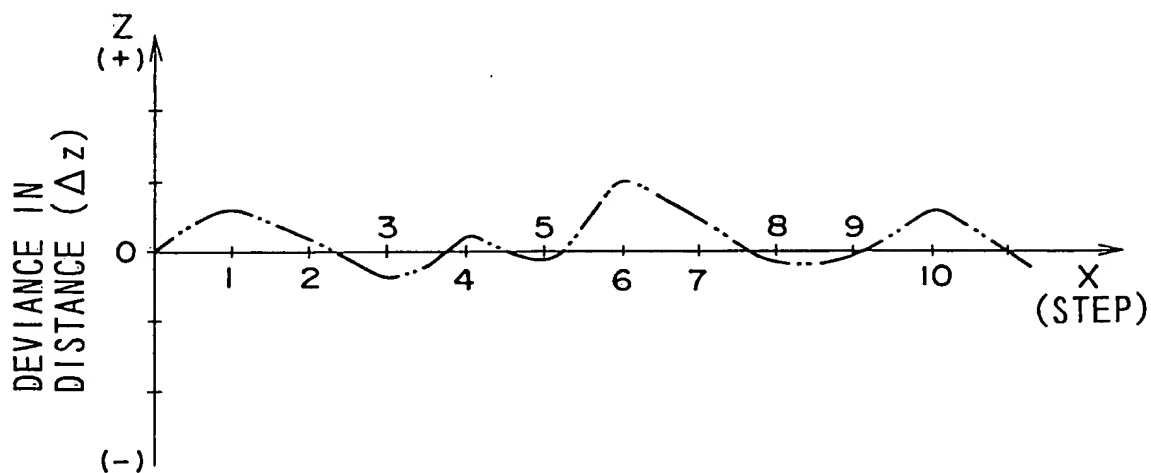
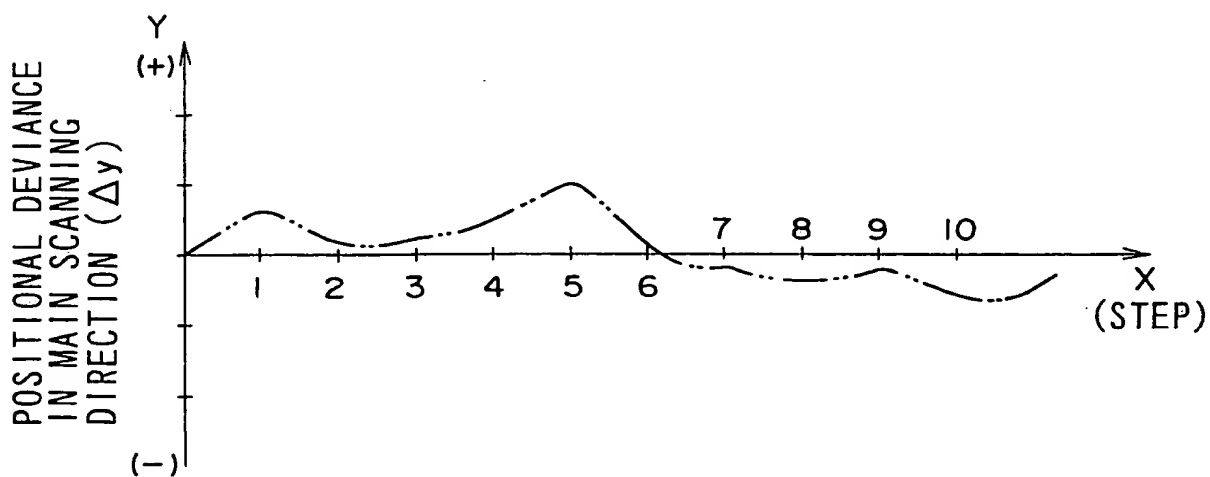
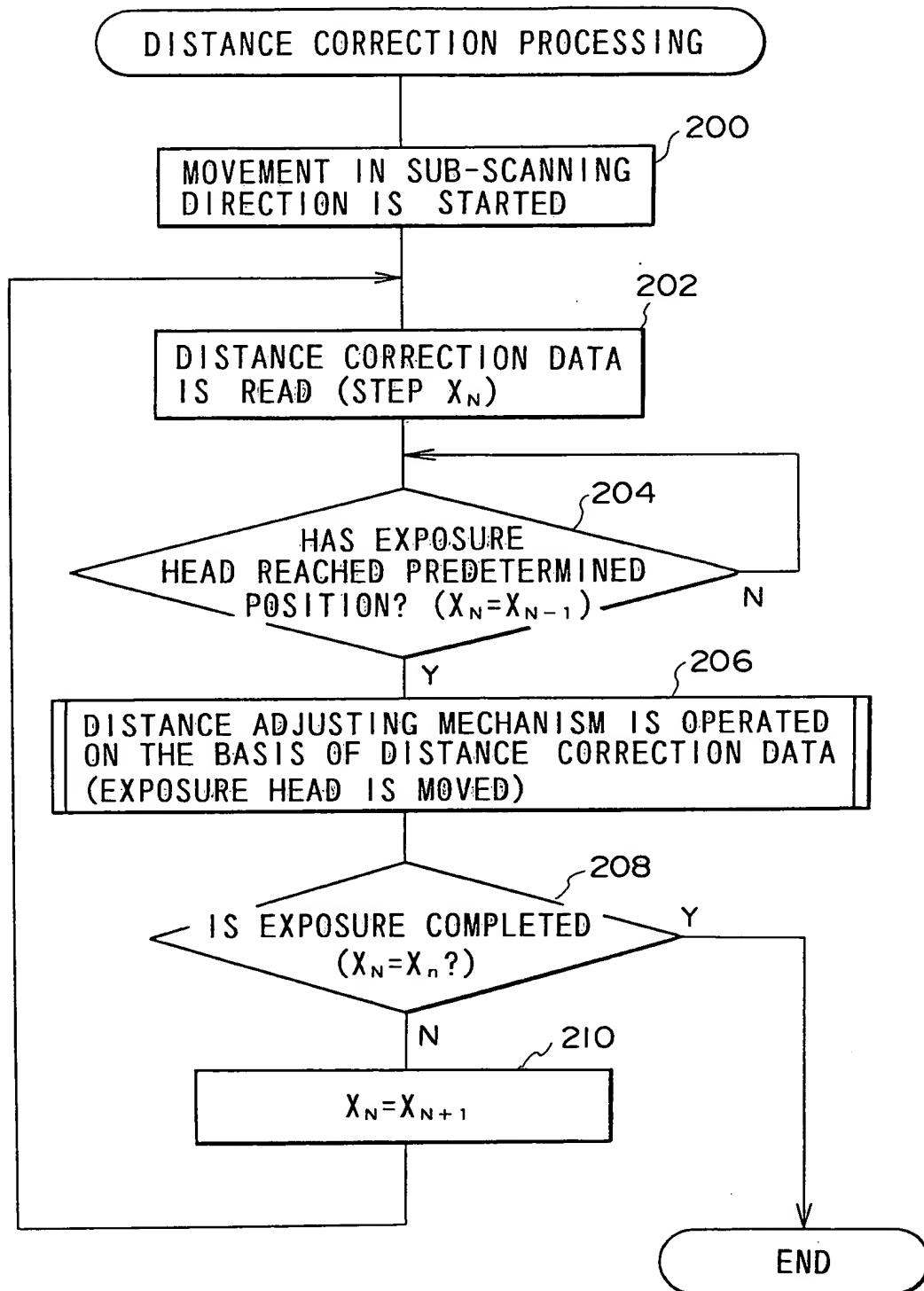


FIG. 6 B



TOTAL 08841660

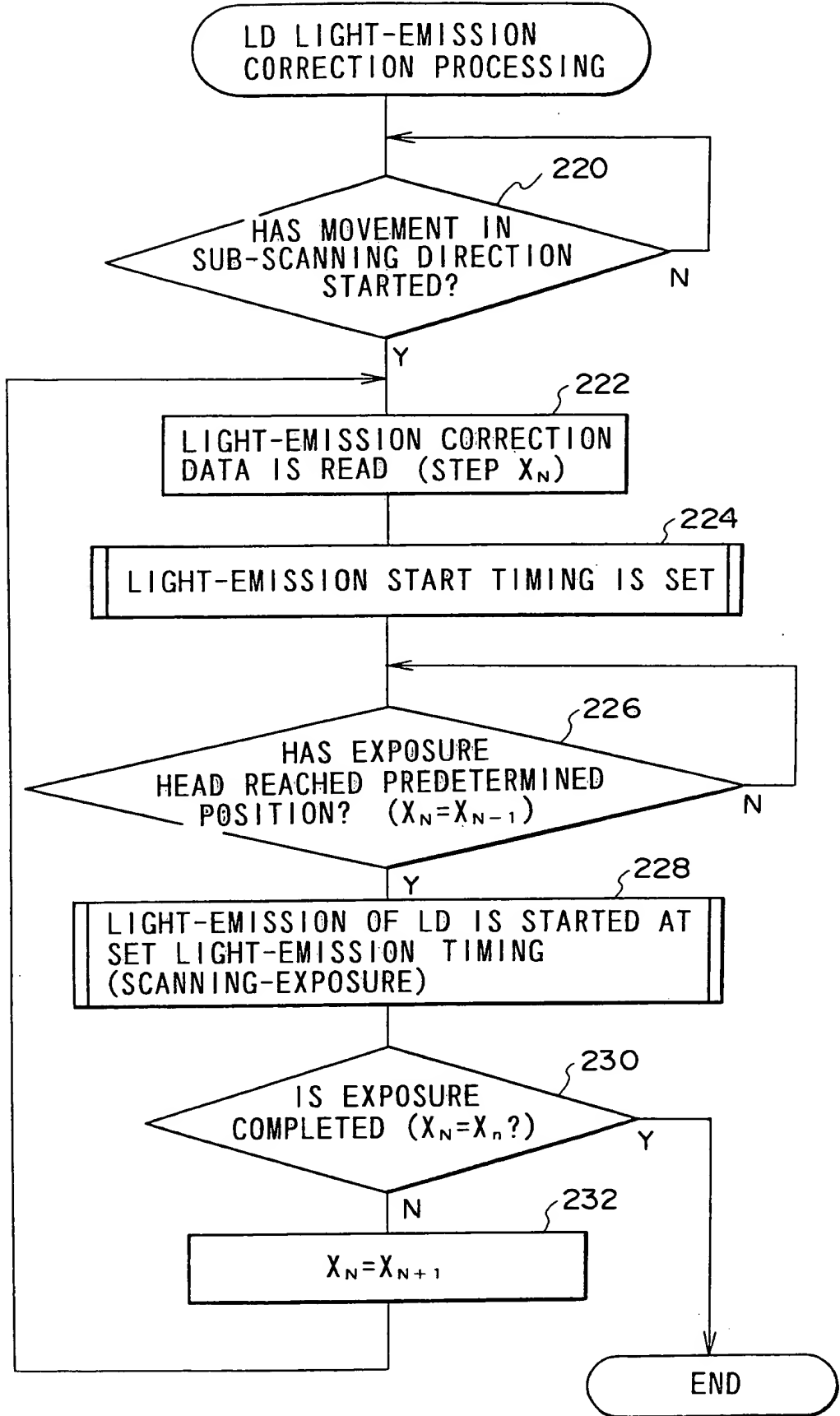
FIG. 7



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DRAFTSMAN: [Signature]

FIG. 8



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